

Day : Wednesday

## PALM INTRANET

Date: 5/19/2004

Time: 10:47:20

## Inventor Name Search Result

Your Search was:

Last Name = OZAKI

First Name = HIROYUKI

Application#	Patent#	Status	Date Filed	Title	Inventor Name 36
<u>10776173</u>	Not Issued	020	02/12/2004	PROCESSING APPARATUS, EXHAUST PROCESSING PROCESS AND PLASMA PROCESSING PROCESS	OZAKI, HIROYUKI
<u>10608546</u>	Not Issued	041	06/30/2003	MODIFIED POLYPROPYLENE AND PROCESS FOR PRODUCING SAME	OZAKI, HIROYUKI
<u>10320430</u>	Not Issued	030	12/17/2002	VACUUM-PROCESSING APPARATUS AND METHOD FOR VACUUM-PROCESSING AN OBJECT	OZAKI, HIROYUKI
<u>10203545</u>	Not Issued	041	10/10/2002	SYNDIOTACTIC STYRENE POLYMERS AND PROCESS FOR THE PRODUCTION THEREOF	OZAKI, HIROYUKI
<u>10166759</u>	<u>6737123</u>	150	06/12/2002	SILICON-BASED FILM FORMATION PROCESS, SILICON-BASED FILM, SEMICONDUCTOR DEVICE, AND SILICON-BASED FILM FORMATION SYSTEM	OZAKI, HIROYUKI
<u>10009094</u>	Not Issued	094	11/08/2001	PROCESS FOR PRODUCING OLEFIN LIVING POLYMER	OZAKI, HIROYUKI
<u>09954049</u>	<u>6681146</u>	150	09/18/2001	METHOD AND APPARATUS FOR CONTROLLING DRIVER MECHANISM IN NC MACHINE TOOL	OZAKI, HIROYUKI
<u>09822191</u>	Not Issued	071	04/02/2001	EXHAUST PROCESSING METHOD, PLASMA PROCESSING METHOD AND PLASMA PROCESSING APPARATUS	OZAKI, HIROYUKI
<u>09800724</u>	<u>6667240</u>	150	03/08/2001	METHOD AND APPARATUS FOR FORMING DEPOSITED	OZAKI, HIROYUKI

				FILM	
<u>09797566</u>	Not Issued	071	03/05/2001	APPARATUS FOR FORMING DEPOSITED FILM	OZAKI, HIROYUKI
<u>09772987</u>	<u>6547922</u>	150	01/31/2001	VACUUM-PROCESSING APPARATUS AND METHOD FOR VACUUM-PROCESSING AN OBJECT	OZAKI, HIROYUKI
<u>09601469</u>	<u>6653430</u>	150	06/18/2001	BUTADIENE POLYMERS AND PROCESS FOR PRODUCING CONJUGATED DIENE POLYMERS	OZAKI, HIROYUKI
<del>09555890</del>	Not Issued	161	06/18/2001	BUTADIENE POLYMER, PROCESS FOR THE PREPARATION OF CONJUGATED DIENE POLYMERS, AND CATALYST	OZAKI, HIROYUKI
<u>09486967</u>	<u>6455649</u>	150	03/03/2000	CATALYST FOR PRODUCING LIVING OLEFIN POLYMER AND PROCESS FOR PRODUCING THE POLYMER	OZAKI, HIROYUKI
<u>09478885</u>	Not Issued	061	01/07/2000	APPARATUS AND METHOD FOR PROCESSING A SUBSTRATE, AND APPARATUS AND METHOD FOR FORMING A DEPOSITED FILM ON A SUBSTRATE	OZAKI, HIROYUKI
<u>09469797</u>	<u>6576061</u>	150	12/22/1999	APPARATUS AND METHOD FOR PROCESSING A SUBSTRATE	OZAKI, HIROYUKI
<u>09358930</u>	<u>6261862</u>	150	07/23/1999	PROCESS FOR PRODUCING PHOTOVOLTAIC ELEMENT	OZAKI, HIROYUKI
<del>09294367</del>	Not Issued	161	04/20/1999	PROCESSING APPARATUS, EXHAUST PROCESSING PROCESS AND PLASMA PROCESSING	OZAKI, HIROYUKI
<u>08791614</u>	<u>5961717</u>	150	01/31/1997	SYNTHESIS OF PHOSPHORUS-DOPED DIAMOND	OZAKI, HIROYUKI
<u>08622751</u>	<u>5747595</u>	250	03/27/1996	CATALYST FOR THE POLYMERIZATION OF OLEFINS AND PROCESSES FOR THE POLYMERIZATION OF OLEFINS USING THE SAME	OZAKI, HIROYUKI
<u>08233440</u>	<u>5472821</u>	150	04/28/1994	HEAT-DEVELOPABLE	OZAKI, HIROYUKI

				DIFFUSION TRANSFER COLOR PHOTOGRAPHIC MATERIAL	
<u>08176695</u>	<u>5427901</u>	150	01/03/1994	HEAT-DEVELOPABLE COLOR LIGHT-SENSITIVE MATERIAL	OZAKI , HIROYUKI
<del><u>07986989</u></del>	Not Issued	<del>161</del>	10/06/1992	HEAT DEVELOPING COLOR LIGHT-SENSITIVE MATERIAL	OZAKI , HIROYUKI
<u>07845948</u>	<u>5336761</u>	150	03/04/1992	HEAT-DEVELOPABLE DIFFUSION TRANSFER COLOR PHOTOGRAPHIC MATERIAL	OZAKI , HIROYUKI
<u>07766309</u>	<u>5270155</u>	150	09/27/1991	DYE DIFFUSION TRANSFER TYPE HEAT DEVELOPABLE COLOR LIGHT-SENSITIVE MATERIAL	OZAKI , HIROYUKI
<del><u>07684734</u></del>	Not Issued	<del>166</del>	04/15/1991	HEAT DEVELOPABLE COLOR LIGHT-SENSITIVE MATERIAL	OZAKI , HIROYUKI
<u>07671635</u>	<u>5089378</u>	150	03/20/1991	METHOD FOR FORMING AN IMAGE	OZAKI , HIROYUKI
<del><u>07290223</u></del>	Not Issued	<del>166</del>	12/27/1988	METHOD FOR FORMING AN IMAGE	OZAKI , HIROYUKI
<u>07165059</u>	<u>4876184</u>	150	03/07/1988	HEAT-DEVELOPABLE LIGHT- SENSITIVE MATERIAL	OZAKI , HIROYUKI
<u>06942958</u>	<u>5047310</u>	150	12/16/1986	PHOTOGRAPHIC PROCESS OF HEATING DURING DEVELOPMENT AFTER IMAGE EXPOSURE WITH A CONDUCTIVE LAYER CONTAINING CARBON BLACK	OZAKI , HIROYUKI
<u>06922494</u>	<u>4788134</u>	150	10/23/1986	HEAT-DEVELOPABLE PHOTOGRAPHIC LIGHT- SENSITIVE MATERIALS	OZAKI , HIROYUKI
<del><u>06917642</u></del>	Not Issued	<del>161</del>	10/10/1986	METHOD FOR FORMING AN IMAGE	OZAKI , HIROYUKI
<u>06895063</u>	<u>4761361</u>	150	08/11/1986	METHOD FOR FORMING AN IMAGE EMPLOYING ACETYLENE SILVER COMPOUNDS	OZAKI , HIROYUKI
<u>06837128</u>	<u>4816363</u>	150	03/07/1986	PHOTOGRAPHIC ELEMENT	OZAKI , HIROYUKI
<u>06836864</u>	<u>4814254</u>	150	03/07/1986	HEAT DEVELOPABLE	OZAKI , HIROYUKI

				PHOTOGRAPHIC ELEMENT WITH CONDUCTIVE LAYER	
<del>06809671</del>	Not Issued	166	12/16/1985	PHOTOGRAPHIC MATERIAL	OZAKI, HIROYUKI

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	OZAKI	HIROYUKI	

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## Inventor Name Search Result

Your Search was:

Last Name = HORI

First Name = TADASHI

Application#	Patent#	Status	Date Filed	Title	Inventor Name 51
<u>90006155</u>	Not Issued	454	12/10/2001	QUICK ATTACHMENT STRUCTURE FOR DRILL SHANK	HORIE, TADASHI
<u>90006155</u>	Not Issued	454	12/10/2001	QUICK ATTACHMENT STRUCTURE FOR DRILL SHANK	HORIE(3RD PTY. REQ.), TADASHI
<u>29163920</u>	<u>D474497</u>	150	07/16/2002	IMAGE FORMING APPARATUS	HORIKAWA, TADASHI
<u>29163919</u>	<u>D474232</u>	150	07/16/2002	IMAGE FORMING APPARATUS	HORIKAWA, TADASHI
<u>10776173</u>	Not Issued	020	02/12/2004	PROCESSING APPARATUS, EXHAUST PROCESSING PROCESS AND PLASMA PROCESSING PROCESS	HORI, TADASHI
<u>10625041</u>	Not Issued	030	07/23/2003	APPARATUS FOR MANUFACTURING PHOTOVOLTAIC ELEMENTS	HORI, TADASHI
<u>10425652</u>	Not Issued	041	04/30/2003	APPARATUS AND METHOD FOR PROCESSING A SUBSTRATE	HORI, TADASHI
<u>10320430</u>	Not Issued	030	12/17/2002	VACUUM-PROCESSING APPARATUS AND METHOD FOR VACUUM-PROCESSING AN OBJECT	HORI, TADASHI
<u>10085102</u>	Not Issued	161	03/01/2002	METHOD OF MANUFACTURING PHOTOVOLTAIC ELEMENT AND APPARATUS THEREFOR	HORI, TADASHI
<u>10066665</u>	<u>6681088</u>	150	02/06/2002	PROCESS CARTRIDGE, IMAGE FORMING APPARATUS AND SEPARATING MECHANISM FOR SEPARATING DEVELOPING MEMBER FROM	HORIKAWA, TADASHI

				PHOTOSENSITIVE DRUM	
10058322	6653165	150	01/30/2002	METHODS OF FORMING SEMICONDUCTOR ELEMENT, AND SEMICONDUCTOR ELEMENTS	HORI, TADASHI
09972993	6553189	150	10/10/2001	OPTICAL GUIDE, PROCESS CARTRIDGE, AND ELECTROPHOTOGRAPHIC IMAGE FORMING APPARATUS	HORIKAWA, TADASHI
09876121	6587660	150	06/08/2001	DEVELOPING APPARATUS	HORIKAWA, TADASHI
09822191	Not Issued	071	04/02/2001	EXHAUST PROCESSING METHOD, PLASMA PROCESSING METHOD AND PLASMA PROCESSING APPARATUS	HORI, TADASHI
09797566	Not Issued	071	03/05/2001	APPARATUS FOR FORMING DEPOSITED FILM	HORI, TADASHI
09772987	6547922	150	01/31/2001	VACUUM-PROCESSING APPARATUS AND METHOD FOR VACUUM-PROCESSING AN OBJECT	HORI, TADASHI
09710862	6385416	150	11/14/2000	SPACE SECURING MEMBER, DEVELOPING DEVICE, CHARGING DEVICE AND PROCESS CARTRIDGE	HORIKAWA, TADASHI
09664219	6368944	150	09/18/2000	METHOD OF MANUFACTURING PHOTOVOLTAIC ELEMENT AND APPARATUS THEREFOR	HORI, TADASHI
09625840	6447612	150	07/26/2000	FILM-FORMING APPARATUS FOR FORMING A DEPOSITED FILM ON A SUBSTRATE, AND VACUUM-PROCESSING APPARATUS AND METHOD FOR VACUUM-PROCESSING AN OBJECT	HORI, TADASHI
09594563	6399411	150	06/15/2000	METHOD FOR FORMING NON-SINGLE-CRYSTAL SEMICONDUCTOR THIN FILM, AND METHOD FOR PRODUCING PHOTOVOLTAIC DEVICE	HORI, TADASHI
09478885	Not Issued	061 F763	01/07/2000 1/8/1993	APPARATUS AND METHOD FOR PROCESSING A SUBSTRATE, AND APPARATUS	HORI, TADASHI JPW

				AND METHOD FOR FORMING A DEPOSITED FILM ON A SUBSTRATE	
09469797	6576061	150	12/22/1999	APPARATUS AND METHOD FOR PROCESSING A SUBSTRATE	HORI, TADASHI
09290265	6144820	150	04/13/1999	DEVELOPING APPARATUS WITH A SEALING MEMBER HAVING AN INSULATING LAYER AND A CONDUCTIVE PORTION	HORIKAWA, TADASHI
09260044	6482668	150	03/02/1999	PROCESS FOR PRODUCING PHOTOVOLTAIC DEVICE	HORI, TADASHI
08990915	6159300	150	12/15/1997	APPARATUS FOR FORMING NON-SINGLE-CRYSTAL SEMICONDUCTOR THIN FILM, METHOD FOR FORMING NON-SINGLE-CRYSTAL SEMICONDUCTOR THIN FILM, AND METHOD FOR PRODUCING PHOTOVOLTAIC DEVICE	HORI, TADASHI
08923259	6162988	150	09/04/1997	PHOTOVOLTAIC ELEMENT	HORI, TADASHI
08800512	6153013	150	02/14/1997	DEPOSITED-FILM-FORMING APPARATUS	HORI, TADASHI
08782811	5927994	150	01/13/1997	METHOD FOR MANUFACTURING THIN FILM, AND DEPOSITION APPARATUS	HORI, TADASHI
08759712	6012006	150	12/06/1996	CREW MEMBER DETECTING DEVICE	HORIKOSHI, TADASHI
08754066	5968274	150	11/20/1996	CONTINUOUS FORMING METHOD FOR FUNCTIONAL DEPOSITED FILMS AND DEPOSITION APPARATUS	HORI, TADASHI
08741352	5946587	150	10/29/1996	CONTINUOUS FORMING METHOD FOR FUNCTIONAL DEPOSITED FILMS	HORI, TADASHI
08717629	5897332	150	09/23/1996	METHOD FOR MANUFACTURING PHOTOELECTRIC CONVERSION ELEMENT	HORI, TADASHI
08697783	5769963	150	08/30/1996	PHOTOVOLTAIC DEVICE	HORI, TADASHI
08697684	Not	161	08/28/1996	PHOTOVOLTAIC CELL AND	HORI, TADASHI

NO

WINK

NO

NO

NO

NO

	Issued			METHOD OF AND APPARATUS FOR ITS FABRICATION	
<u>08657066</u>	<u>5720826</u>	150	05/29/1996	PHOTOVOLTAIC ELEMENT AND FABRICATION PROCESS THEREOF	HORI, TADASHI
<u>08610076</u>	<u>5919310</u>	150	02/29/1996	CONTINUOUSLY FILM- FORMING APPARATUS PROVIDED WITH IMPROVED GAS GATE MEANS	HORI, TADASHI
<u>08545507</u>	<u>5841598</u>	150	10/19/1995	INFORMATION RECORDING/REPRODUCING APPARATUS AND DATA PROCESSING METHOD	HORIUCHI, TADASHI
<u>08523169</u>	<u>5589007</u>	150	09/05/1995	PHOTOVOLTAIC ELEMENTS AND PROCESS AND APPARATUS FOR THEIR FORMATION	HORI, TADASHI
<u>08433052</u>	<u>5575855</u>	150	05/03/1995	APPARATUS FOR FORMING A DEPOSITED FILM	HORI, TADASHI
<del><u>08416468</u></del>	<del>Not Issued</del>	<del>166</del>	04/04/1995	CONTINUOUS FORMING METHOD FOR FUNCTIONAL DEPOSITED FILMS AND DEPOSITION THEREOF	HORI, TADASHI
<del><u>08404616</u></del>	<del>Not Issued</del>	<del>166</del>	03/15/1995	CONTINUOUS FORMING METHOD FOR FUNCTIONAL DEPOSITED FILMS AND DEPOSITION APPARATUS	HORI, TADASHI
<del><u>08559817</u></del>	<del>Not Issued</del>	<del>164</del>	12/20/1994	PHOTOVOLTAIC CELL AND METHOD OF AND APPARATUS FOR ITS FABRICATION	HORI, TADASHI
<u>08334032</u>	<u>5468521</u>	150	11/02/1994	METHOD FOR FORMING A PHOTOELECTRIC DEPOSITED FILM	HORI, TADASHI
<u>08299445</u>	<u>5565864</u>	150	09/01/1994	ABSOLUTE ENCODER	HORIKAWA, TADASHI
<del><u>08187550</u></del>	<del>Not Issued</del>	<del>166</del>	01/28/1994	PHOTOVOLTAIC ELEMENTS AND PROCESS AND APPARATUS FOR THEIR FORMATION	HORI, TADASHI
<del><u>08101018</u></del>	<del>Not Issued</del>	<del>166</del>	08/03/1993	CONTINUOUS FORMING METHOD FOR FUNCTIONAL DEPOSITED FILMS AND DEPOSITION APPARATUS	HORI, TADASHI
<del><u>07967238</u></del>	<del>Not Issued</del>	<del>166</del>	10/27/1992	DEPOSITED FILM FORMING METHOD AND DEPOSITED FILM FORMING APPARATUS	HORI, TADASHI



NO

NO

NO

07641795	5110729	150	01/16/1991	METHOD OF PRODUCING PEPTIDES USING BACULOVIRUS VECTORS IN CULTURED CELLS	HORIUCHI, TADASHI
07268972	4869075	150	11/09/1988	AIR CONDITIONER	HORI, TADASHI
<del>06930489</del>	Not Issued	<del>166</del>	11/14/1986	METHOD OF PRODUCING PEPTIDES	HORIUCHI, TADASHI
06880314	4669534	150	06/30/1986	AIR CONDITIONER	HORI, TADASHI

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## Inventor Name Search Result

Your Search was:

Last Name = HORI

First Name = TADASHI

Application#	Patent#	Status	Date Filed	Title	Inventor Name 10
09439609	6602347	150	11/12/1999	APPARATUS AND METHOD FOR PROCESSING A SUBSTRATE	HORI, TADASHI
09411974	6373146	150	10/04/1999	OCCUPANT PROTECTION APPARATUS	HORIKOSHI, TADASHI
09385059	6549735	150	08/30/1999	DEVELOPING APPARATUS WITH LONGITUDINAL END LEAKAGE PREVENTING MEMBER IN CONTACT WITH SMOOTH SURFACE PART OF A DEVELOPER CARRYING MEMBER	HORIKAWA, TADASHI
09375998	6195515	150	08/19/1999	A DEVELOPING APPARATUS INCLUDING A SEAL MEMBER SANDWICHED BETWEEN A DEVELOPER BEARING MEMBER AND A LEAKAGE PREVENTING MEMBER	HORIKAWA, TADASHI
09358930	6261862	150	07/23/1999	PROCESS FOR PRODUCING PHOTOVOLTAIC ELEMENT	HORI, TADASHI
<del>09294367</del>	Not Issued	161	04/20/1999	PROCESSING APPARATUS, EXHAUST PROCESSING PROCESS AND PLASMA PROCESSING	HORI, TADASHI
09257027	6530341	150	02/25/1999	DEPOSITION APPARATUS FOR MANUFACTURING THIN FILM	HORI, TADASHI
08927413	6159763	150	09/10/1997	METHOD AND DEVICE FOR FORMING SEMICONDUCTOR THIN FILM, AND METHOD AND DEVICE FOR FORMING PHOTOVOLTAIC ELEMENT	HORI, TADASHI
08800512	6153013	150	02/14/1997	DEPOSITED-FILM-FORMING	HORI, TADASHI

updated from 1st set of TH !!!

				APPARATUS	
<del>08070476</del>	Not Issued	<del>161</del>	10/14/1993	CONTINUOUSLY FILM- FORMING APPARATUS PROVIDED WITH IMPROVED GAS GATE MEANS	HORI , TADASHI

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Day : Wednesday

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## Inventor Name Search Result

Your Search was:

Last Name = TSUZUKI

First Name = HIDETOSHI

Application#	Patent#	Status	Date Filed	Title	Inventor Name 20
<u>10776173</u>	Not Issued	020	02/12/2004	PROCESSING APPARATUS, EXHAUST PROCESSING PROCESS AND PLASMA PROCESSING PROCESS	TSUZUKI, HIDETOSHI
<u>10704693</u>	Not Issued	030	11/12/2003	STACKED PHOTOVOLTAIC DEVICE	TSUZUKI, HIDETOSHI
<u>10606956</u>	Not Issued	030	06/27/2003	PLATING APPARATUS AND METHOD	TSUZUKI, HIDETOSHI
<u>10300305</u>	Not Issued	030	11/20/2002	ELECTRODE MATERIAL FOR RECHARGEABLE LITHIUM BATTERY, ELECTRODE STRUCTURAL BODY COMPRISING SAID ELECTRODE MATERIAL, RECHARGEABLE LITHIUM BATTERY HAVING SAID ELECTRODE STRUCTURAL BODY, PROCESS FOR THE PRODUCTION OF SAID ELECTRODE STRUCTURAL BODY, AND PROCESS FOR THE PRODUCTION OF SAID RECHARGEABLE LITHIUM BATTERY	TSUZUKI, HIDETOSHI
<u>10195543</u>	Not Issued	041	07/16/2002	METHOD AND APPARATUS FOR FORMING DEPOSITION FILM, AND METHOD FOR TREATING SUBSTRATE	TSUZUKI, HIDETOSHI
<u>10157490</u>	<u>6703555</u>	150	05/30/2002	SOLAR CELL STRING, SOLAR CELL ARRAY AND SOLAR PHOTOVOLTAIC POWER SYSTEM	TSUZUKI, HIDETOSHI
<u>10157144</u>	Not Issued	041	05/30/2002	SOLAR-BATTERY ARRAY, AND PHOTOVOLTAIC POWER	TSUZUKI, HIDETOSHI

				GENERATION SYSTEM	
<u>10050787</u>	Not Issued	093	01/18/2002	SPUTTERING METHOD AND SPUTTERING APPARATUS	TSUZUKI, HIDETOSHI
<u>09953256</u>	6576112	150	09/17/2001	METHOD OF FORMING ZINC OXIDE FILM AND PROCESS FOR PRODUCING PHOTOVOLTAIC DEVICE USING IT	TSUZUKI, HIDETOSHI
<u>09844071</u>	6562400	150	04/30/2001	METHOD AND APPARATUS FOR FORMING DEPOSITION FILM, AND METHOD FOR TREATING SUBSTRATE	TSUZUKI, HIDETOSHI
<u>09822191</u>	Not Issued	071	04/02/2001	EXHAUST PROCESSING METHOD, PLASMA PROCESSING METHOD AND PLASMA PROCESSING APPARATUS	TSUZUKI, HIDETOSHI
<u>09694274</u>	6373455	150	10/24/2000	ELECTROLUMINESCENCE DEVICE, ELECTROLUMINESCENCE APPARATUS, AND PRODUCTION METHODS THEREOF	TSUZUKI, HIDETOSHI
<del>09342920</del>	<del>Not Issued</del>	<del>161</del>	<del>06/30/1999</del>	<del>ELECTROLUMINESCENCE DEVICE, ELECTROLUMINESCENCE APPARATUS, AND PRODUCTION METHODS THEREOF</del>	<del>TSUZUKI, HIDETOSHI</del>
<del>09294367</del>	<del>Not Issued</del>	<del>161</del>	<del>04/20/1999</del>	<del>PROCESSING APPARATUS, EXHAUST PROCESSING PROCESS AND PLASMA PROCESSING</del>	<del>TSUZUKI, HIDETOSHI</del>
<u>09187398</u>	6236416	150	11/06/1998	IMAGE FORMING APPARATUS FEATURING A PLURALITY OF LIGHT EMISSION ELEMENTS ON A SINGLE CHIP	TSUZUKI, HIDETOSHI
<u>09089257</u>	6016037	150	06/03/1998	ELECTROLUMINESCENCE APPARATUS AND DRIVING METHOD THEREOF	TSUZUKI, HIDETOSHI
<u>09084994</u>	6175345	150	05/28/1998	ELECTROLUMINESCENCE DEVICE, ELECTROLUMINESCENCE APPARATUS, AND PRODUCTION METHODS THEREOF	TSUZUKI, HIDETOSHI

NO	<u>08878113</u>	<u>6154265</u>	150	06/18/1997	LIQUID CRYSTAL DEVICE AND PRODUCTION PROCESS THEREOF	TSUZUKI, HIDETOSHI
NO	<u>08874458</u>	<u>6252641</u>	150	06/17/1997	LIQUID CRYSTAL DEVICE AND LIQUID CRYSTAL APPARATUS	TSUZUKI, HIDETOSHI
NO	<u>08648996</u>	<u>5933128</u>	150	05/17/1996	CHIRAL SMECTIC LIQUID CRYSTAL APPARATUS AND DRIVING METHOD THEREFOR	TSUZUKI, HIDETOSHI

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**Inventor Name Search Result**

Your Search was:

Last Name = MORIYAMA

First Name = KOICHIRO

Application#	Patent#	Status	Date Filed	Title	Inventor Name 18
<u>10776173</u>	Not Issued	020	02/12/2004	PROCESSING APPARATUS, EXHAUST PROCESSING PROCESS AND PLASMA PROCESSING PROCESS	MORIYAMA, KOICHIRO
<u>10425652</u>	Not Issued	041	04/30/2003	APPARATUS AND METHOD FOR PROCESSING A SUBSTRATE	MORIYAMA, KOICHIRO
<u>10320430</u>	Not Issued	030	12/17/2002	VACUUM-PROCESSING APPARATUS AND METHOD FOR VACUUM-PROCESSING AN OBJECT	MORIYAMA, KOICHIRO
<u>10113675</u>	Not Issued	092	04/02/2002	PROCESS FOR FORMING A SILICON-BASED FILM ON A SUBSTRATE USING A TEMPERATURE GRADIENT ACROSS THE SUBSTRATE AXIS	MORIYAMA, KOICHIRO
<u>10101859</u>	Not Issued	160	03/21/2002	METHOD OF FORMING SILICON-BASED THIN FILM, SILICON-BASED THIN FILM, AND PHOTOVOLTAIC ELEMENT	MORIYAMA, KOICHIRO
<u>09822191</u>	Not Issued	071	04/02/2001	EXHAUST PROCESSING METHOD, PLASMA PROCESSING METHOD AND PLASMA PROCESSING APPARATUS	MORIYAMA, KOICHIRO
<u>09800724</u>	<u>6667240</u>	150	03/08/2001	METHOD AND APPARATUS FOR FORMING DEPOSITED FILM	MORIYAMA, KOICHIRO
<u>09772987</u>	6547922	150	01/31/2001	VACUUM-PROCESSING APPARATUS AND METHOD FOR VACUUM-PROCESSING AN OBJECT	MORIYAMA, KOICHIRO

09625840	6447612	150	07/26/2000	FILM-FORMING APPARATUS FOR FORMING A DEPOSITED FILM ON A SUBSTRATE, AND VACUUM-PROCESSING APPARATUS AND METHOD FOR VACUUM-PROCESSING AN OBJECT	MORIYAMA, KOICHIRO
09478885	Not Issued	061	01/07/2000	APPARATUS AND METHOD FOR PROCESSING A SUBSTRATE, AND APPARATUS AND METHOD FOR FORMING A DEPOSITED FILM ON A SUBSTRATE	MORIYAMA, KOICHIRO
09469797	6576061	150	12/22/1999	APPARATUS AND METHOD FOR PROCESSING A SUBSTRATE	MORIYAMA, KOICHIRO
09439609	6602347	150	11/12/1999	APPARATUS AND METHOD FOR PROCESSING A SUBSTRATE	MORIYAMA, KOICHIRO
09358930	6261862	150	07/23/1999	PROCESS FOR PRODUCING PHOTOVOLTAIC ELEMENT	MORIYAMA, KOICHIRO
09337557	6338872	150	06/22/1999	FILM FORMING METHOD	MORIYAMA, KOICHIRO
09294367	Not Issued	161	04/20/1999	PROCESSING APPARATUS, EXHAUST PROCESSING PROCESS AND PLASMA PROCESSING	MORIYAMA, KOICHIRO
09080922	6031198	150	05/19/1998	PLASMA PROCESSING METHOD AND APPARATUS	MORIYAMA, KOICHIRO
08768609	6350489	150	12/18/1996	DEPOSITED-FILM FORMING PROCESS AND DEPOSITED-FILM FORMING APPARATUS	MORIYAMA, KOICHIRO
08704138	6273955	150	08/28/1996	FILM FORMING APPARATUS AND METHOD	MORIYAMA, KOICHIRO

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Date: 5/19/2004

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## Inventor Name Search Result

Your Search was:

Last Name = TAKAI

First Name = YASUYOSHI

Application#	Patent#	Status	Date Filed	Title	Inventor Name 39
<u>10776173</u>	Not Issued	020	02/12/2004	PROCESSING APPARATUS, EXHAUST PROCESSING PROCESS AND PLASMA PROCESSING PROCESS	TAKAI, YASUYOSHI
<u>10704693</u>	Not Issued	030	11/12/2003	STACKED PHOTOVOLTAIC DEVICE	TAKAI, YASUYOSHI
<u>10606956</u>	Not Issued	030 1753	06/27/2003 (205/138)	PLATING APPARATUS AND METHOD	TAKAI, YASUYOSHI <i>FFW</i>
<u>10397310</u>	Not Issued	030	03/27/2003	LIQUID-PHASE GROWTH METHOD AND LIQUID-PHASE GROWTH APPARATUS	TAKAI, YASUYOSHI
<u>10195543</u>	Not Issued	041	07/16/2002	METHOD AND APPARATUS FOR FORMING DEPOSITION FILM, AND METHOD FOR TREATING SUBSTRATE	TAKAI, YASUYOSHI
<u>10183339</u> <u>20030085116</u>	Not Issued	071 1753	06/28/2002 204/192.26	LONG-TERM SPUTTERING METHOD	TAKAI, <i>FFW</i> YASUYOSHI
<u>10059168</u>	Not Issued	041	01/31/2002	TRANSPARENT CONDUCTIVE FILM FORMATION PROCESS, PHOTOVOLTAIC DEVICE PRODUCTION PROCESS, TRANSPARENT CONDUCTIVE FILM, AND PHOTOVOLTAIC DEVICE	TAKAI, YASUYOSHI
<u>10058802</u>	<u>6716324</u>	150	01/30/2002	METHOD OF FORMING TRANSPARENT, CONDUCTIVE FILM, METHOD OF COMPENSATING DEFECTIVE REGION OF SEMICONDUCTOR LAYER, PHOTOVOLTAIC ELEMENT, AND METHOD OF PRODUCING PHOTOVOLTAIC ELEMENT	TAKAI, YASUYOSHI
<u>10050787</u> 20020134670	Not	093 1753	01/18/2002 204/192.13	SPUTTERING METHOD AND	TAKAI, <i>IFW</i>

	Issued			SPUTTERING APPARATUS	YASUYOSHI
<u>09983427</u>	Not Issued	041	10/24/2001	METHOD OF FORMING SILICON-BASED THIN FILM, METHOD OF FORMING SILICON-BASED SEMICONDUCTOR LAYER, AND PHOTOVOLTAIC ELEMENT	TAKAI, YASUYOSHI
<u>09900010</u>	<u>6694792</u>	150	07/09/2001	SUBSTRATE TREATMENT PROCESS	TAKAI, YASUYOSHI
<u>09844071</u>	<u>6562400</u>	150	04/30/2001	METHOD AND APPARATUS FOR FORMING DEPOSITION FILM, AND METHOD FOR TREATING SUBSTRATE	TAKAI, YASUYOSHI
<u>09822191</u>	Not Issued	071	04/02/2001	EXHAUST PROCESSING METHOD, PLASMA PROCESSING METHOD AND PLASMA PROCESSING APPARATUS	TAKAI, YASUYOSHI
<u>09614548</u>	<u>6452091</u>	150	07/12/2000	METHOD OF PRODUCING THIN-FILM SINGLE-CRYSTAL DEVICE, SOLAR CELL MODULE AND METHOD OF PRODUCING THE SAME	TAKAI, YASUYOSHI
<u>09605759</u>	<u>6406554</u>	150	06/28/2000	METHOD AND APPARATUS FOR PRODUCING ELECTROPHOTOGRAPHIC PHOTOSENSITIVE MEMBER	TAKAI, YASUYOSHI
<u>09334176</u>	<u>6335281</u>	150	06/16/1999	DEPOSITED FILM FORMING PROCESS	TAKAI, YASUYOSHI
<del>09294367</del>	Not Issued	<del>161</del>	04/20/1999	PROCESSING APPARATUS, EXHAUST PROCESSING PROCESS AND PLASMA PROCESSING	TAKAI, YASUYOSHI
<u>09218633</u>	<u>6103442</u>	150	12/22/1998	METHOD AND APPARATUS FOR PRODUCING ELECTROPHOTOGRAPHIC PHOTOSENSITIVE MEMBER	TAKAI, YASUYOSHI
<u>09186421</u>	<u>6156472</u>	150	11/05/1998	METHOD OF MANUFACTURING ELECTROPHOTOGRAPHIC PHOTOSENSITIVE MEMBER	TAKAI, YASUYOSHI
<u>09110124</u>	<u>6223684</u>	150	07/06/1998	FILM DEPOSITION APPARATUS	TAKAI, YASUYOSHI
<u>08989233</u>	<u>6158382</u>	150	12/12/1997	METHOD FOR FORMING A DEPOSITED FILM BY PLASMA	TAKAI, YASUYOSHI

				CHEMICAL VAPOR DEPOSITION AND APPARATUS FOR FORMING A DEPOSITED FILM BY PLASMA CHEMICAL VAPOR DEPOSITION	
<u>08967208</u>	<u>6365308</u>	150	10/29/1997	LIGHT RECEIVING MEMBER FOR ELECTROPHOTOGRAPHY	TAKAI, YASUYOSHI
<u>08916540</u>	<u>6435130</u>	150	08/22/1997	PLASMA CVD APPARATUS AND PLASMA PROCESSING METHOD	TAKAI, YASUYOSHI
<u>08916007</u>	<u>5943531</u>	150	08/21/1997	ELECTROPHOTOGRAPHIC APPARATUS, IMAGE FORMING METHOD, AND PROCESS FOR FABRICATING LIGHT RECEIVING MEMBER FOR ELECTROPHOTOGRAPHY	TAKAI, YASUYOSHI
<u>08814588</u>	<u>5853936</u>	150	03/10/1997	LIGHT RECEIVING MEMBER, SUBSTRATE FOR SAID LIGHT RECEIVING MEMBER, AND ELECTROPHOTOGRAPHIC APPARATUS HAVING SAID LIGHT RECEIVING MEMBER	TAKAI, YASUYOSHI
<u>08307099</u>	<u>5597623</u>	150	09/16/1994	PROCESS FOR USING MICROWAVE PLASMA CVD	TAKAI, YASUYOSHI
<u>08200651</u>	<u>5480627</u>	150	02/23/1994	METHOD FOR TREATING SUBSTRATE FOR ELECTROPHOTOGRAPHIC PHOTOSENSITIVE MEMBER AND METHOD FOR MAKING ELECTROPHOTOGRAPHIC PHOTOSENSITIVE MEMBER	TAKAI, YASUYOSHI
<u>08196111</u>	<u>5624776</u>	150	02/18/1994	ELECTROPHOTOGRAPHIC PHOTOSENSITIVE MEMBER PROVIDED WITH A LIGHT RECEIVING LAYER COMPOSED OF A NON-SINGLE CRYSTAL SILICON MATERIAL CONTAINING COLUMNAR STRUCTURE REGIONS AND PROCESS FOR THE PRODUCTION THEREOF	TAKAI, YASUYOSHI
<u>08173948</u>	<u>5443645</u>	150	12/28/1993	MICROWAVE PLASMA CVD APPARATUS COMPRISING COAXIALLY ALIGNED MULTIPLE GAS PIPE GAS FEED STRUCTURE	TAKAI, YASUYOSHI



				MANUFACTURING ELECTROPHOTOGRAPHIC PHOTOSENSITIVE MEMBER MAKING USE OF SAID METHOD FOR TREATING SUBSTRATE	
<del>07820644</del>	Not Issued	<del>166</del>	01/21/1992	MICROWAVE PLASMA CVD APPARATUS	TAKAI, YASUYOSHI
<del>07780780</del>	5273851	150	10/23/1991	ELECTROPHOTOGRAPHIC LIGHT-RECEIVING MEMBER	TAKAI, YASUYOSHI

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## Inventor Name Search Result

Your Search was:

Last Name = KODA

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Application#	Patent#	Status	Date Filed	Title	Inventor Name 23
<u>10650763</u>	Not Issued	030	08/29/2003	APPARATUS AND METHOD FOR FORMING DEPOSITED FILM	KODA, YUZO
<u>10113675</u>	Not Issued	092	04/02/2002	PROCESS FOR FORMING A SILICON-BASED FILM ON A SUBSTRATE USING A TEMPERATURE GRADIENT ACROSS THE SUBSTRATE AXIS	KODA, YUZO
<u>10058322</u>	<u>6653165</u>	150	01/30/2002	METHODS OF FORMING SEMICONDUCTOR ELEMENT, AND SEMICONDUCTOR ELEMENTS	KODA, YUZO
<u>09912343</u>	<u>6472296</u>	150	07/26/2001	FABRICATION OF PHOTOVOLTAIC CELL BY PLASMA PROCESS	KODA, YUZO
<u>09911172</u>	<u>6495392</u>	150	07/23/2001	PROCESS FOR PRODUCING A SEMICONDUCTOR DEVICE	KODA, YUZO
<u>09822191</u>	Not Issued	071	04/02/2001	EXHAUST PROCESSING METHOD, PLASMA PROCESSING METHOD AND PLASMA PROCESSING APPARATUS	KODA, YUZO
<u>09797566</u>	Not Issued	071	03/05/2001	APPARATUS FOR FORMING DEPOSITED FILM	KODA, YUZO
<u>09771650</u>	<u>6470823</u>	150	01/30/2001	APPARATUS AND METHOD FOR FORMING A DEPOSITED FILM BY MEANS OF PLASMA CVD	KODA, YUZO
<u>09767856</u>	<u>6632284</u>	150	01/24/2001	APPARATUS AND METHOD FOR FORMING DEPOSITED FILM	KODA, YUZO
<u>09645036</u>	Not Issued	164	08/24/2000	PROCESS FOR PRODUCING A	KODA, YUZO

	Issued			SEMICONDUCTOR DEVICE	
<u>09625840</u>	<u>6447612</u>	150	07/26/2000	FILM-FORMING APPARATUS FOR FORMING A DEPOSITED FILM ON A SUBSTRATE, AND VACUUM-PROCESSING APPARATUS AND METHOD FOR VACUUM-PROCESSING AN OBJECT	KODA, YUZO
<u>09578906</u>	<u>6436797</u>	150	05/26/2000	APPARATUS AND METHOD FOR FORMING A DEPOSITED FILM ON A SUBSTRATE	KODA, YUZO
<u>09363825</u>	<u>6287943</u>	150	07/30/1999	DEPOSITION OF SEMICONDUCTOR LAYER BY PLASMA PROCESS	KODA , YUZO
<u>08697783</u>	<u>5769963</u>	150	08/30/1996	PHOTOVOLTAIC <u>DEVICE</u>	KODA , YUZO
<u>08657066</u>	<u>5720826</u>	150	05/29/1996	PHOTOVOLTAIC ELEMENT AND FABRICATION PROCESS THEREOF	KODA , YUZO
<u>08337195</u>	<u>5439533</u>	150	11/07/1994	PHOTOVOLTAIC DEVICE, METHOD OF PRODUCING THE SAME AND GENERATING SYSTEM USING THE SAME	KODA , YUZO
<u>08289258</u>	<u>5510631</u>	150	08/11/1994	NON-MONOCRYSTALLINE SILICON <u>CARBIDE</u> SEMICONDUCTOR AND SEMICONDUCTOR DEVICE EMPLOYING THE SAME	KODA , YUZO
<u>08188731</u>	<u>5371380</u>	150	01/31/1994	SI- AND/OR GE-CONTAINING NON-SINGLE CRYSTALLINE SEMICONDUCTOR FILM WITH AN AVERAGE RADIUS OF 3.5 Å OR LESS AS FOR MICROVOIDS CONTAINED THEREIN AND A MICROVOID DENSITY OF 1 X 10(19) (CM-3) OR LESS	KODA , YUZO
<u>08155655</u>	<u>5418680</u>	150	11/22/1993	APPARATUS FOR REPAIRING AN <u>ELECTRICALLY SHORT-CIRCUITED</u> SEMICONDUCTOR DEVICE	KODA , YUZO
<del>08083284</del>	Not Issued	<del>166</del>	06/29/1993	PHOTOVOLTAIC DEVICE, METHOD OF PRODUCING THE SAME AND GENERATING SYSTEM USING THE SAME	KODA , YUZO
<del>08045788</del>	Not Issued	<del>166</del>	04/14/1993	SI- AND/OR GE-CONTAINING NON-SINGLE CRYSTALLINE	KODA , YUZO

				SEMICONDUCTOR FILM WITH AN AVERAGE RADIUS OF 3.5 Å OR LESS AS FOR MICROVOIDS CONTAINED THEREIN AND A MICROVOID DENSITY OF 1 X 10 <sup>19</sup> (CM-3) OR LESS	
<u>07840537</u>	<u>5362684</u>	150	02/25/1992	NON-MONOCRYSTALLINE SILICON CARBIDE SEMICONDUCTOR, PROCESS OF PRODUCTION THEREOF, AND SEMICONDUCTOR DEVICE EMPLOYING THE SAME	KODA , YUZO
<u>07755439</u>	<u>5281541</u>	150	09/05/1991	METHOD FOR REPAIRING AN ELECTRICALLY SHORT-CIRCUITED SEMICONDUCTOR DEVICE, AND PROCESS FOR PRODUCING A SEMICONDUCTOR DEVICE UTILIZING SAID METHOD	KODA , YUZO

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